



AF IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SEKIYA, Kazuma

Serial No.: 10/721,234

Filed: November 26, 2003

For: LASER MACHINING METHOD

Art Unit: 1725

Examiner: Heinrich, Samuel M.

Atty. Dckt: 033773M056

RESPONSE UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop: AF

Dear Sir:

This is in response to the Office action mailed May 9, 2006, to which the time for response was set to expire August 9, 2006. The pending claims, claims 7 and 12, were rejected. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper.
Remarks begin on page 3 of this paper.